

Transaction Information

Tool ID	STP421
Tool Status	Connected
Location	Dresden, Germany
Wafer Size	300 mm
Fab Section	Lithography
Tool Available Date	2025-02-01

General Product Information

Vendor Supplier	NIKON
Model	NIKON NSR-S208D
Vintage	2005
Serial No	S62A0560001
Asset Description	Lithography Step and repeat scanning system
Software Version	1.80 MCSW+OCS
CIM	SECS
Process	Exposure Wafers (248nm) KrF

Hardware Configuration

System Type	Description	Quantity	Status
Handler System	Reticle Handler System	1	OK
Handler System	Wafer Handler System	1	OK
Factory Interface	FOUP	1	OK
Others	A/C Bower Box	1	OK
Others	Chamber_Filter_Cabinett LFU	1	OK
Main System	Step and Repeat Scanning System	1	OK
Others	Chiller	1	OK
Options System	CYMER Laser ELS-7410	1	OK

Excluded Items List (Pumps, Chillers & Abatement are all excluded)

Description	Quantity
NONE	0

Tool Pictures

General	Exposure Unit
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Manufacture Serial

Mainbody + Laser SN Plate

MODEL NO. S62

SERIAL NO. S62A 0560001

DATE 2005.10

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Nikon

SENDAI NIKON CORP.
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